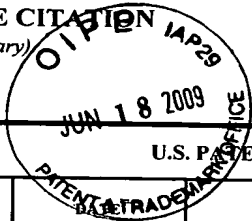


**INFORMATION DISCLOSURE CITATION**  
(Use several sheets if necessary)



Docket Number (Optional)

**SH-0069PCTUS**

Application Number

**10/594,529**

Applicant(s)

**Tetsuya OTOSAKA**

Filing Date

**September 28, 2006**

Group Art Unit

**1791**

**U.S. PATENT DOCUMENTS**

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

**U.S. PATENT APPLICATION PUBLICATIONS**

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
		<b>US 2003/0015004 A1</b>	<b>1/23/2003</b>	<b>Nakamura et al.</b>			

**FOREIGN PATENT DOCUMENTS**

REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						YES	NO
	<b>CN1397507</b>	<b>2/19/2003</b>	<b>China</b>			<b>ABS</b>	

**OTHER DOCUMENTS**

(Including Author, Title, Date, Pertinent Pages, Etc.)

	<b>Chinese Office Action dated May 8, 2009 with English-language translation.</b>

EXAMINER	DATE CONSIDERED
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EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.